WHAT IS CLAIMED IS

- 1. A drop ejection device, comprising:
- a flow path in which fluid is pressurized to eject drops from a nozzle opening, a piezoelectric actuator for pressurizing said fluid, and one or more waste fluid control apertures proximate the nozzle opening, the aperture being in communication with a vacuum source.
- 2. The device of claim 1 including fluid control apertures which are spaced from the nozzle opening by about 200% of the nozzle opening width or less.
- 3. The device of claim 1 including fluid control apertures which are spaced from the nozzle opening by about 200% to about 1000% of the nozzle opening width or less.
- 4. The device of claim 1 wherein the control apertures are in communication with the flow path in which fluid is pressurized.
- 5. The device of claim 1 wherein each control aperture has a fluid resistance of about 25 times or more than the fluidic resistance of the nozzle opening.
- 6. The device of claim 1 wherein the average total flow through the apertures is about 10% or less than the average flow through the nozzle opening.
- 7. The device of claim 1 wherein each aperture has a width of about 30% or less than the width of the nozzle opening.
- 8. The device of claim 1 wherein the width of the nozzle opening is about 200 microns or less.
- 9. The device of claim 1 wherein each control aperture has a diameter of about 10 microns or less.

- 10. The device of claim 1 including a nonwetting coating proximate the nozzle opening.
- 11. The device of claim 1 wherein the flow path, nozzle opening, and control aperture are defined in common body.
 - 12. The device of claim 11 wherein the body is a silicon material.
- 13. The device of claim 1 wherein the control apertures are isolated from the flow path.
- 14. The device of claim 1 wherein the control apertures include a wicking material.
- 15. The device of claim 1 wherein the control apertures communicate with a waste container.
 - 16. A drop ejection device, comprising:

a flow path in which fluid is pressurized to eject drops from a nozzle opening, a piezoelectric actuator, and one or more fluid control apertures, the fluid control apertures being spaced from the nozzle opening by a distance of about 200% of the nozzle opening width or less, and each aperture having an aperture width of about 30% or less than the width of the nozzle opening.

- 17. The device of claim 16 includes at least three apertures.
- 18. The device of claim 16 including a nonwetting coating adjacent the nozzle opening.

- 19. The device of claim 16 wherein the control apertures are isolated from the flow path.
- 20. The device of claim 16 wherein the flow path, nozzle opening, and control aperture are defined in common body.
 - 21. A drop ejection device, comprising:

a flow path in which fluid is pressurized to eject drops from a nozzle opening, and one or more fluid control apertures, the fluid control apertures including a wicking material.

- 22. The device of claim 21 wherein the wicking material protrudes from the control aperture.
 - 23. A method of ejecting fluid, comprising:

providing a fluid drop ejection apparatus including a nozzle opening and at least one waste fluid control aperture, the waste fluid control aperture in communication with a vacuum,

ejecting fluid at a frequency of about 10 KHZ or greater, and drawing waste fluid through said aperture in an amount of about 5% or less of the fluid ejected at an operating vacuum of about 5 inches of water or less.

- 24. The method of claim 23 including at least three apertures.
- 25. The method of claim 23 comprising drawing about 2% of fluid ejected at about 2 inches of water or less.
- 26. The method of claim 23 wherein the control aperture and the nozzle opening are in communication with a common fluid supply and the fluid supply and the vacuum are communicated through said fluid supply.

- 27. The method of claim 23 wherein the control aperture is about 30% or less the diameter of the nozzle opening.
- 28. The method of claim 23 wherein the diameter of the nozzle opening is about 200 microns or less.
 - 29. A method of ejecting fluid, comprising:

providing a fluid drop ejection apparatus including a nozzle opening and at least one waste fluid control aperture, and

without ejecting a drop, directing a bolus of said fluid through the nozzle opening in a manner to communicate with said aperture.

- 30. The method of claim 29 comprising periodically directing a bolus of fluid to maintain fluid in said aperture.
 - 31. The method of claim 29 comprising suspending said directions of fluid to said bolus, and ejecting a drop from said nozzle opening.
- 32. The method of claim 29 wherein the fluid control aperture communicates with a vacuum.
- 33. The method of claim 29 wherein the control aperture and the nozzle opening are in communication with a common fluid supply and the fluid supply and the vacuum is communicated through said fluid supply.